

Notice of References Cited	Application/Control No. 10/651,328		Applicant(s)/Patent Under Reexamination KANG ET AL.	
	Examiner Philip Wang		Art Unit 2191	Page 1 of 1

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	"Debugging HDF5 Applications", http://hdf.ncsa.uiuc.edu/HDF5/doc/Debugging.html , printed on 11/30/2006
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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